RADICALLY DIFFERENT ETCH TECHNOLOGY

The Applied Producer™ Selectra™ Etch System Unprecedented Selectivity for Sustained Scaling

MORE COMPLEX DEVICES INTRODUCE NEW MATERIALS

DISRUPTIVE TECHNOLOGY REQUIRED FOR CONTINUED SCALING





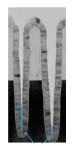


FinFFT

Gate All Around

3D NAND

DIMENSIONS CHALLENGE TRADITIONAL ETCH

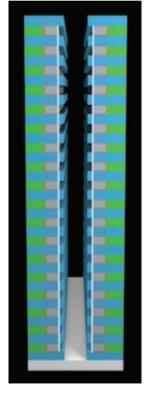




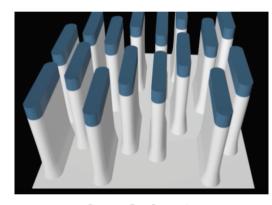


High Aspect Ratios

The industry's first extreme selectivity etch system introduces new materials engineering capabilities for future generations of self-aligned patterning schemes and 3D logic and memory devices.



Unparalleled Uniformity



Damage-Free Processing

